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Investigation on origin of $Z_{1/2}$ center in SiC by deep level transient spectroscopy and electron paramagnetic resonance

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The $Z_{1/2}$ center in n-type 4H-SiC epilayers—a dominant deep level limiting the carrier lifetime—has been investigated. Using capacitance versus voltage (C - V) measurements and deep level transient spectroscopy (DLTS), we show that the $Z_{1/2}$ center is responsible for the carrier compensation in n-type 4H-SiC epilayers irradiated by low-energy (250 keV) electrons. The concentration of the $Z_{1/2}$ defect obtained by C - V and DLTS correlates well with that of the carbon vacancy (V_C) determined by electron paramagnetic resonance, suggesting that the $Z_{1/2}$ deep level originates from V_C . © 2013 American Institute of Physics. [<http://dx.doi.org/10.1063/1.4796141>]

SiC is an attractive semiconductor for realizing high-power, high-temperature, and high-frequency devices. Deep levels in semiconductors can act either as carrier traps reducing the conductivity or recombination centers limiting the carrier lifetimes. The $Z_{1/2}$ center^{1–3} is one of the most important deep levels in 4H-SiC, known as a lifetime killer.^{4,5} The origin of the $Z_{1/2}$ center seems to include a carbon vacancy (V_C) because (i) this defect is generated by irradiation with electrons of energy as low as 100 keV,^{6–8} which corresponds to the threshold energy that can displace only carbon atoms in SiC and (ii) a lower $Z_{1/2}$ concentration is observed in SiC epilayers grown under C-rich condition.⁹

Based on the correlation between the energy determined by deep level transient spectroscopy (DLTS) for the $Z_{1/2}$ center and by electron paramagnetic resonance (EPR) for the single negative C vacancy ($V_C(-)$),¹⁰ the $Z_{1/2}$ center has recently been suggested to be the acceptor level of V_C .¹¹ In this paper, we will show the correlation in concentration between the $Z_{1/2}$ defect (obtained by capacitance-voltage (C - V) and DLTS) and V_C (determined by EPR) in n-type 4H-SiC irradiated by low-energy (250 keV) electrons with various electron fluences.

A direct comparison of the defect concentration determined by DLTS (or C - V) and by EPR is not easy. EPR measurements are suitable for relatively high defect concentrations ($>10^{12}$ spins), which require high electron fluences to create. However, materials irradiated with high electron fluences often become highly resistive and are not suitable for DLTS and C - V measurements. Therefore, in previous studies, samples used for DLTS were irradiated with much lower electron fluences compared to samples used for EPR measurements.¹² In this study, in order to be able to characterize the same samples in C - V , DLTS, and EPR experiments, we chose n-type thick 4H-SiC epilayers with a relatively high N concentration ($N_d \sim 1.6 \times 10^{17} \text{ cm}^{-3}$) so

that the materials can still be used for electrical measurements after irradiation with high electron fluences.

The starting materials are n-type 4H-SiC epilayers (thickness: 100 μm , $N_d: 1.6 \times 10^{17} \text{ cm}^{-3}$). The epilayers were irradiated by 250 keV electrons with different fluences: (A) $7.5 \times 10^{18} \text{ cm}^{-2}$, (B) $7.2 \times 10^{18} \text{ cm}^{-2}$, (C) $5.7 \times 10^{18} \text{ cm}^{-2}$, (D) $4.3 \times 10^{18} \text{ cm}^{-2}$, and (E) $3.1 \times 10^{18} \text{ cm}^{-2}$. Ni/SiC Schottky structures have been made on the samples used for C - V , I - V , and DLTS measurements while the substrate of the other set of samples to be used for EPR was removed by mechanical polishing. For data sampling in all DLTS measurements, a period width of 0.205 s and a frequency of 1 MHz were employed. In DLTS measurements, the reverse bias voltage was varied in the range of 0–100 V, which corresponds to the monitored depth of about 100–800 nm in samples A–E. EPR measurements were performed on an X-band ($\sim 9.4 \text{ GHz}$) Bruker E500 spectrometer equipped with a continuous He-flow cryostat, allowing the sample temperature regulation in the range of 4–295 K. In photoexcitation EPR (photo-EPR) experiments, a 200 W halogen lamp and appropriate optical filters were used for excitation.

Figure 1(a) shows the C - V characteristics at room temperature (RT) obtained from SiC irradiated with different fluences. The capacitance of samples A–D is very small and almost constant independent of the bias voltage, indicating that these samples have a completely compensated region (CR) caused by electron capture of deep levels (these samples have a very thick depletion region even under 0 V bias). Figure 1(b) shows the dependence of the CR thickness (d_{CR}) on the electron fluence, which was derived from the equation: $d_{\text{CR}} = \epsilon/C$, where ϵ the dielectric constant and C the capacitance per unit area obtained from Fig. 1(a). Samples irradiated with a higher fluence show a thicker CR, indicating that deep levels are not uniformly distributed along the depth. Figure 2 shows depth profiles of the $Z_{1/2}$ center in lower doping 4H-SiC epilayers ($N_d \sim 1.6 \times 10^{15} \text{ cm}^{-3}$; initial $Z_{1/2}$ concentration: $1.7 \times 10^{13} \text{ cm}^{-3}$) after 250 keV electron irradiation with various fluences ($3 \times 10^{15} \text{ cm}^{-2}$, $1 \times 10^{16} \text{ cm}^{-2}$, and $2 \times 10^{16} \text{ cm}^{-2}$). Because the CR region is formed where the trap concentration exceeds the doping

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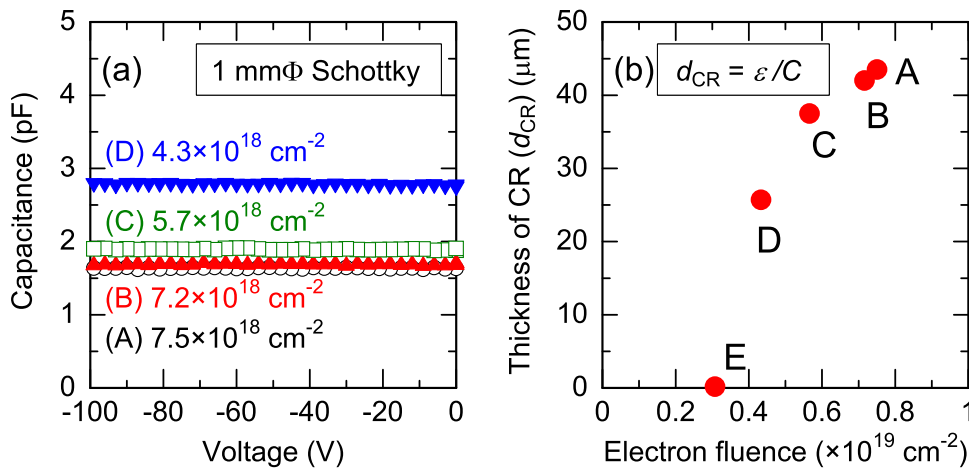


FIG. 1. (a) C-V characteristics at RT of samples irradiated by low-energy (250 keV) electrons with various fluences (circles: $7.5 \times 10^{18} \text{ cm}^{-2}$, triangles: $7.2 \times 10^{18} \text{ cm}^{-2}$, squares: $5.7 \times 10^{18} \text{ cm}^{-2}$, reverse triangles: $4.3 \times 10^{18} \text{ cm}^{-2}$). (b) Thickness of the compensated region (d_{CR}) in samples A–E calculated from the constant capacitance shown in Fig. 1(a).

concentration, a higher electron fluence should lead to a thicker d_{CR} as shown in Fig. 1(b).

Figure 3 shows DLTS spectra observed in samples A and E. The spectrum in the lower temperature region of sample A was obtained by current deep level transient spectroscopy (I-DLTS) because the very low capacitance (caused by severe compensation) disturbed capacitance deep level transient spectroscopy (C-DLTS) measurements. At higher temperatures ($>400 \text{ K}$), the capacitance recovered to the value before electron irradiation, which enabled C-DLTS measurements of irradiated samples. As shown in Fig. 3, ET1 ($E_{\text{C}} - 0.30 \text{ eV}$),⁷ EH₁ ($E_{\text{C}} - 0.34 \text{ eV}$),¹³ Z_{1/2} ($E_{\text{C}} - 0.67 \text{ eV}$),¹ EH₃ ($E_{\text{C}} - 0.72 \text{ eV}$),¹³ EH₅ ($E_{\text{C}} - 1.2 \text{ eV}$),¹³ ET4 ($E_{\text{C}} - 1.3 \text{ eV}$), and EH_{6/7} ($E_{\text{C}} - 1.5 \text{ eV}$)¹³ centers were observed in the irradiated samples. The activation energy was derived with assuming a temperature independent capture cross section (σ). Taking into account that the activation energy for σ of Z_{1/2} center (which corresponds to the barrier for capturing the second electron to the Z_{1/2} level) is 0.074 eV ,^{14,15} the energy level of Z_{1/2} center is recalculated to be at $\sim E_{\text{C}} - 0.59 \text{ eV}$. All these deep levels are often observed in irradiated 4H-SiC except for the ET4 center, which is not easy to be separated from the EH_{6/7} center because of severe overlapping. Among these centers, the Z_{1/2} center has the highest

concentration although the absolute concentration could not be evaluated due to very high trap concentrations (the Z_{1/2} concentration in sample E is about $1 \times 10^{17} \text{ cm}^{-3}$ while N_{d} is $1.6 \times 10^{17} \text{ cm}^{-3}$).

Figure 4 shows the carrier concentration (filled circles) and the Fermi level (circles) in the CR of samples A–E. The carrier concentration n in the CR was roughly estimated from the resistivity ρ in the CR of each sample using the equation: $n = 1/e\rho\mu$. The ρ value was calculated from the series resistance of Schottky barrier diodes (R) obtained from I - V measurements using the equation: $\rho = R/d_{\text{CR}}$. The electron mobility μ in the CR was assumed to be $370 \text{ cm}^2/\text{Vs}$ using empirical equations given in a paper.¹⁶ For this estimation of μ , an ionized impurity concentration of $3.2 \times 10^{17} \text{ cm}^{-3}$ was used because there should be ionized donors of $1.6 \times 10^{17} \text{ cm}^{-3}$ and traps filled with electrons of $1.6 \times 10^{17} \text{ cm}^{-3}$. The Fermi level E_{F} in the CR can be estimated from the carrier concentration n using the equation: $E_{\text{F}} = E_{\text{C}} - kT \ln(N_{\text{C}}/n)$, and E_{F} is evaluated to be approximately at $E_{\text{C}} - 0.53 \text{ eV}$ in samples A–D, which is close to the energy level of the Z_{1/2} center as shown in Fig. 4. With the Fermi level located at $E_{\text{C}} - 0.53 \text{ eV}$, the Z_{1/2} center ($E_{\text{C}} - 0.59 \text{ eV}$) is occupied with electrons (the occupancy $\sim 91\%$ at 300 K). Taking into account that Z_{1/2} has the highest concentration (over $1 \times 10^{17} \text{ cm}^{-3}$) among deep levels observed in these samples, this defect should be the dominant compensating center, creating the CR.

It has been shown that in darkness most of V_{C} are in the double negative charge state, giving rise to no EPR signal.¹¹ The observation of the EPR signal of $V_{\text{C}}(-)$ requires illumination. In all samples, the EPR signal of $V_{\text{C}}(-)$ is found to be dominant, suggesting that the acceptor levels of V_{C} play a key role in the formation of the CR in studied samples. Figure 5 shows the dependence of the area density of $V_{\text{C}}(-)$ in the samples A–E obtained by EPR measurements under illumination with light of photon energy smaller than 1.6 eV , and the value $0.1N_{\text{d}}d_{\text{CR}}$ on the electron fluence. It should be noted here that under illumination, V_{C} can be in the neutral, single-negative, or double-negative charge state.¹¹ The $V_{\text{C}}(-)$ volume density should be limited by N_{d} because an electron is needed for V_{C} to become $V_{\text{C}}(-)$. The value $N_{\text{d}}d_{\text{CR}}$ corresponds to the maximum value of the $V_{\text{C}}(-)$ area density under an assumption that almost all $V_{\text{C}}(-)$ signal comes from the CR. The assumption is reasonable because

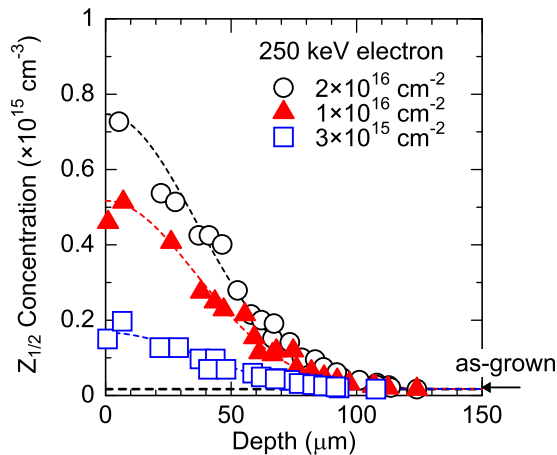


FIG. 2. Depth profiles of the Z_{1/2} center in low-doped 4H-SiC epilayers ($N_{\text{d}}: 1.6 \times 10^{15} \text{ cm}^{-3}$, initial Z_{1/2} concentration: $1.7 \times 10^{13} \text{ cm}^{-3}$) after 250-keV-electron irradiation with various fluences (circles: $2 \times 10^{16} \text{ cm}^{-2}$, triangles: $1 \times 10^{16} \text{ cm}^{-2}$, squares: $3 \times 10^{15} \text{ cm}^{-2}$).

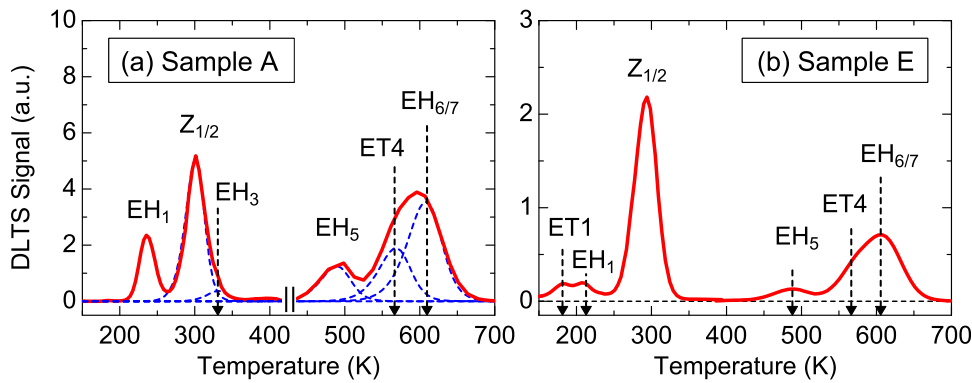


FIG. 3. DLTS spectra observed in samples (a) A (electron fluence: $7.5 \times 10^{18} \text{ cm}^{-2}$) and (b) E (electron fluence: $3.1 \times 10^{18} \text{ cm}^{-2}$). The lower temperature region of the spectrum in sample A was obtained by I-DLTS.

the V_C density in the CR is much higher than that in the tail uncompensated region, and most of V_C in the tail region should be in the double-negative ($2-$) charge state since the concentration of V_C is lower than that of donor concentration and the Fermi level is near the N shallow donor. As shown in Fig. 5, 10% of $N_d d_{CR}$ shows a good agreement with the

$V_C(-)$ area density obtained by EPR measurements, indicating that under illumination at 100 K, about 10% of electrons in the CR exists as $V_C(-)$, while most of the other electrons may do as $V_C(2-)$. Note that the calculated value $0.1 N_d d_{CR}$ in the sample E is considerably smaller than the $V_C(-)$ area density obtained by EPR. Although the assumption that the EPR signal of $V_C(-)$ comes mainly from the CR is reasonable for samples A–D with thick CR, it is not valid for sample E, which has a very thin CR and the amount of V_C in the uncompensated region cannot be neglected compared to that in the very thin CR ($\sim 0.17 \mu\text{m}$). Neglecting the contribution of V_C in the uncompensated region leads to the underestimation of the value $N_d d_{CR}$ in sample E. These EPR results with V_C having the highest density among all defects in the samples A–E and the $V_C(-)$ density following the maximum value of $V_C(-)$ density limited by N_d indicate that V_C is the dominant defect creating the CR.

Comparing the data obtained from DLTS, C - V , and EPR measurements, it is clear that (i) the dominant deep level in samples A–E is the $Z_{1/2}$ center and the dominant point defect is V_C and (ii) the compensation in irradiated samples is caused by electron capture to the $Z_{1/2}$ center (as shown from DLTS) and to the acceptor levels of V_C (as shown in EPR). Thus, the $Z_{1/2}$ center, which capture two electrons as known from DLTS,¹⁴ should be related to the double negative charge state of V_C (it is known that the EH_7 DLTS level and

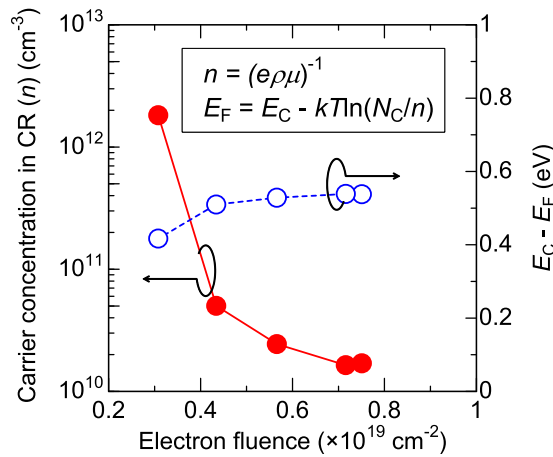


FIG. 4. The dependence on the electron fluence of the carrier concentration n and the Fermi level at 300 K in the CR in samples A–E. Here, n was estimated from the resistivity ρ in the CR for each sample.

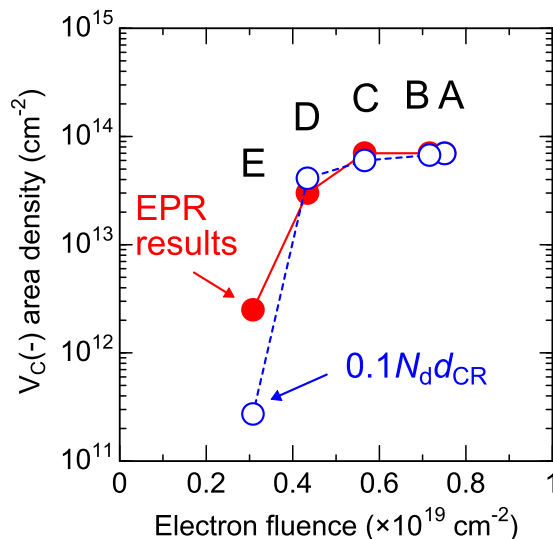


FIG. 5. Electron fluence dependence of the area density of carbon vacancy in the single-negative charge state ($V_C(-)$) in samples A–E obtained by EPR measurements under illumination with light of photon energy smaller than 1.6 eV, and the $0.1 N_d d_{CR}$ value. $N_d d_{CR}$ corresponds to the maximum $V_C(-)$ area density.

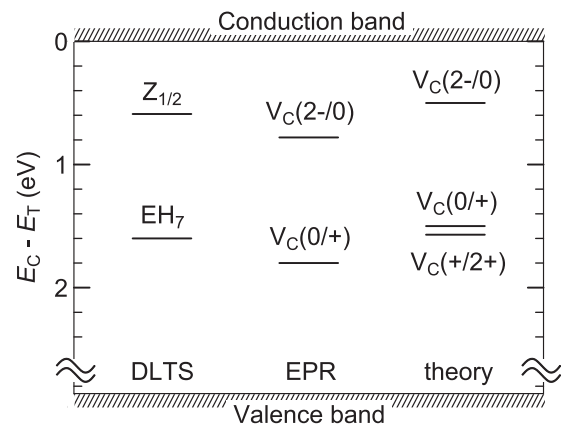


FIG. 6. Overview of the activation energy of deep levels obtained by DLTS (in this paper) and the energy of the ($2-/0$) and ($0/+$) levels of V_C determined by photo-EPR (Ref. 11) with respect to the conduction band minimum. The optical transitions determined by EPR involve a possible Franck-Condon shift, which has to be taken into account to be compared with the activation energy determined by DLTS. The energy levels of V_C in different charge states obtained by *ab initio* calculation (Ref. 18) are also shown for comparison.

the $Z_{1/2}$ center originate from the same defect,^{7,17} and EH_7 is related to the $(0/+)$ charge state of V_C (Ref. 11)).

Figure 6 shows the activation energy (E_{act}) of deep levels obtained by DLTS and the optical transition levels related to V_C levels (E_{exc}) determined by photo-EPR¹¹ with respect to the conduction band edge ($E_C = 0$). To compare E_{exc} with E_{act} , a possible Franck-Condon shift involved in the optical transitions has to be taken into account ($E_{\text{act}} = E_{\text{exc}} - E_{\text{FC}}$). The activation energy of V_C obtained by *ab initio* calculations¹⁸ are also shown in Fig. 6, which agrees well with the energy levels obtained by DLTS and EPR measurements.

In summary, using n-type 4H-SiC epitaxial layers irradiated by low-energy (250 keV) electrons, which can mainly create defects in the C sub-lattice (V_C , C interstitials and their associated defects) with different fluences, we were able to employ different techniques (C - V , DLTS, and EPR) to study the $Z_{1/2}$ and V_C defects in the same samples. It has been shown that $Z_{1/2}$ and V_C are the dominant defects responsible for the carrier compensation observed in the irradiated samples, suggesting that the $Z_{1/2}$ center originates from a C vacancy and is related to the EPR inactive 2- charge state of V_C .

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